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PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
Shunpei Yamazaki	12/16/2013
Hideomi Suzawa	12/17/2013
Hiroshi Fujiki	12/18/2013
Hiromichi Godo	12/19/2013
Yasumasa Yamane	12/17/2013

RECEIVING PARTY DATA

Name:	SEMICONDUCTOR ENERGY LABORATORY CO., LTD.
Street Address:	398, HASE
City:	ATSUGI-SHI, KANAGAWA-KEN
State/Country:	JAPAN
Postal Code:	243-0036

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	14141831

CORRESPONDENCE DATA

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ATTORNEY DOCKET NUMBER:	12732-1270001
NAME OF SUBMITTER:	APRIL K. SAUNDERS-FULLER
	1 PAIENI

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Signature:	/April K. Saunders-Fuller/
Date:	01/09/2014
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ASSIGNMENT

For valuable consideration, We. <u>Shunpei YAMAZAKI of Setagaya</u>, <u>Tokyo</u>, <u>Japan, Hideomi SUZAWA of Atsugi, Kanagawa, Japan, Hiroshi FUJIKI of Atsugi, Kanagawa, Japan, Hiromichi GODO of Isehara, Kanagawa, Japan and Yasumasa YAMANE of Atsugi, Kanagawa, Japan hereby assign to <u>Semiconductor Energy Laboratory Co., Ltd.</u>, a <u>Japanese</u> corporation having a place of business at:</u>

398, Hase, Atsugi-shi, Kanagawa-ken, 243-0036 Japan

and its successors and assigns (collectively hereinafter called "the Assignee"), the entire right, title and
interest throughout the world in the inventions and improvements which are subject of an application for
United States Patent signed by us this day, entitled <u>SEMICONDUCTOR DEVICE AND METHOD FOR</u>
MANUFACTURING THE SAME, filed December 27, 2013 and assigned U.S. Serial
Number 14/141,831, and we authorize and request the attorneys appointed in said application
to hereafter complete this assignment by inserting above the filing date and serial number of said application
when known; this assignment including said application, any and all United States and foreign patents.
utility models, and design registrations granted for any of said inventions or improvements, and the right to
claim priority based on the filing date of said application under the International Convention for the
Protection of Industrial Property, the Patent Cooperation Treaty, the European Patent Convention, and all
other treaties of like purposes; and we authorize the Assignee to apply in all countries in our name or in its
own name for patents, utility models, design registrations and like rights of exclusion and for inventors'
certificates for said inventions and improvements; and we agree for ourselves and our respective heirs, legal
representatives and assigns, without further compensation to perform such lawful acts and to sign such
further applications, assignments, Preliminary Statements and other lawful documents as the Assignee may
reasonably request to effectuate fully this assignment.

Signature	Slugu Bungali
Name:	Shunpei YAMAZAKI
Date:	12/16/2013
Signature Name: Date:	Africami Buzawa Hideomi SUZAWA 12/17/2013
	12/1/2015
Signature	Hiraki Tujiki
Name:	Hiroshi FUJIKI
Date:	12/18/2013

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Signatur Name: Hiromichi GODO

Date: 12/19/2013

Signatur Yasumasa Yamane

 Name:
 Yasumasa YAMANE

 Date:
 12/17/2013

PATENT REEL: 031927 FRAME: 0444

RECORDED: 01/09/2014